

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Michitaka Urushima

Serial No.:

09/839,298

**Group Art Unit:** 

2829

Filed:

April 23, 2001

**Examiner:** 

Geyer, Scott B.

SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD OF THE

**SAME** 

Honorable Commissioner of Patents

Washington, D.C. 20231

## AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

In response to the Office Action dated May 9, 2002, please amend the above-

identified application as follows:

**IN THE CLAIMS:** 

Please cancel claims 10-24 without prejudice or disclaimer.

TECHNOLOGY CENTER 2800

Please amend claims 2, 5 and 7-9 as follows:

(Amended) the semiconductor device according to claim 1, further comprising:

an interposer bonded through thermocompression bonding.

(Amended) A semiconductor device comprising:

a semiconductor chip;

an adhesive layer formed on a surface of said semiconductor chip on which an electrode is formed;